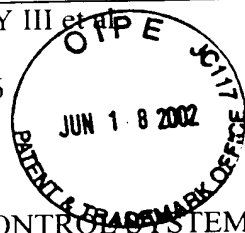


GP/176

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BAILEY III et al
Application No.: 09/943,806
Filed: 08/30/2001
Title: TEMPERATURE CONTROL SYSTEM
FOR PLASMA PROCESSING APPARATUS



Attorney Docket No.: LAM1P124D1
Examiner: ALENJANDERO MULERO, L.
Group: 1763

COPY OF PAPERS
ORIGINALLY FILED

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to Box Non-Fee Amendment, Commissioner for Patents, Washington, DC 20231 on June 11, 2002.

Signed: *Sandra Halliwell*
Sandra Halliwell

AMENDMENT TRANSMITTED

RECEIVED
JUN 27 2002
TC 1700

COPY OF PAPERS
ORIGINALLY FILED

Box Non-Fee Amendment
Commissioner for Patents
Washington, DC 20231

Sir:
Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	16	MINUS	20	0	x 9 =	x 18 =
Independent Claims	03	MINUS	03	0	x 42 =	x 84 =
Multiple Dependent Claim Present and Fee Not Previously Paid					\$140.00	\$280.00
Total					\$	\$0.00

- ☐ Applicant(s) hereby petition for a ____ month extension(s) of time to respond to the aforementioned Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388 (Order No. LAM1P124D1).
- ☐ Enclosed is our Check No. ____ in the amount of \$ ____ to cover the additional claim fee and/or extension of time fees.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. LAM1P124D1).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP

Francis T. Kalinski II

Francis T. Kalinski II
Reg. No. 44,177

P.O. Box 778
Berkeley, CA 94704-0778

5.5



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BAILEY III et al.

Attorney Docket No.: LAM1P124D1

Application No.: 09/943,806

Examiner: Alejandro Mulero, Luz L

Filed: August 30, 2001

Group: 1763

Title: TEMPERATURE CONTROL SYSTEM
FOR PLASMA PROCESSING APPARATUS

9B
704.2
M
RECEIVED
JUN 27 2002
TC 1700

COPY OF PAPERS
ORIGINALLY FILED

CERTIFICATE OF MAILING
I hereby certify that this correspondence is being deposited with
the United States Postal Service as First Class Mail to Box Non-
Fee Amendment, Commissioner for Patents, Washington, DC
20231 on June 11, 2002.

Signed: 

Sandra Halliwell

AMENDMENT A

Box Non-Fee Amendment
Commissioner for Patents
Washington, DC 20231

Sir:

COPY OF PAPERS
ORIGINALLY FILED

This Amendment is in response to the Office Action (identified as paper no. 8) mailed April 9, 2002. Kindly amend the above-entitled application as set forth below.

In The Claims:

Please **AMEND** claims 23-27 as follows:

(Amended) 23. A method for providing temperature control to a plasma processing chamber of a plasma processing apparatus, said method comprising:

directly or indirectly measuring temperature internal to the plasma processing chamber;

comparing the measured temperature to a target temperature;

heating the plasma processing chamber by heating a plurality of thermal control blocks arranged around the sides of the plasma processing chamber such that the thermal control blocks are [that is] thermally coupled to the plasma processing chamber; and